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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): A. Smith et al.

Serial No.: 10/775,718

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Cust. No.: 33123

For: **METHOD AND APPARATUS FOR
SELF-REFERENCED WAFER
STAGE POSITIONAL ERROR
MAPPING**

CERTIFICATE OF MAILING
PURSUANT TO 37 CFR 1.8

I hereby certify that this correspondence and the attached papers are being deposited with the United States Postal Service with sufficient postage as first class mail on the date indicated below in an envelope addressed to:

Commissioner for Patents
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Michelle Melende
Signature

PRELIMINARY AMENDMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Preliminary to the examination of the above-identified divisional application, please enter the following amendment and consider the following remarks.

Amendments to the specification begin on Page 2 of this document.

Remarks begin on Page 23 of this document.